IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application Serial No. 10/822,060
Filing Date .... April 8, 2004
Inventor .... Ross S. Dando
Assignee .... Micron Technology, Inc.
Group Art Unit... 1763
Examiner .... Karla A. Moore
Attorney's Docket No. MI22-2518
Title: Deposition Apparatuses

INFORMATION DISCLOSURE STATEMENT

The attached Form PTO-1449 is submitted in compliance with 37 CFR §1.56. Pursuant to FEDERAL REGISTER, Vol. 69, No. 182, pg. 56542 (September 21, 2004), no copies of any cited U.S. patents or U.S. published applications are included herewith. Copies of all other cited art are attached. No admission is made regarding whether the listed references are prior art.

Citation of these patent references is respectfully requested.

A check in the amount of $180.00 is enclosed to cover the fee specified under 37 C.F.R. § 1.17(p).

Respectfully submitted,

Dated: _10/3/06_

By: _____
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Form PTO-1449	U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE	ATTY. DOCKET NO. MI22-2518	SERIAL NO. 10/822,060
LIST OF ART CITED BY APPLICANT (Use several sheets if necessary)		APPLICANT: Ross S. Dando	
		FILING DATE April 8, 2004	GROUP 1763

U.S. PATENT DOCUMENTS

*Examiner's Initials		Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate
	AA	5,364,667	11/94	Rhieu, Ji H.			
	AB	5,556,476	9/96	Lei, et al.			
	AC	5,782,974	7/98	Sorensen, et al.			
	AD	6,079,426	06/00	Subrahmanyam, et al.			
	AE	6,333,272	12/01	McMillin et al.			
	AF	6,530,994	3/03	Mahawili, et al.			
	AG	6,994,769	02/06	Singh, et al.			
	AH	2001/0010228	08/01	Au et al.			
	AI	2002/0129768	09/02	Carpenter, et al.			
		2003/0005958	01/03	Rocha-Alvarez et al.			
		2004/0000321	01/04	Cui et al.			
		2005/0057826	03/06	DeBoer, Wiebe			

FOREIGN PATENT DOCUMENTS

		Document Number	Date	Country	Class	Subclass	Translation	
							Yes	No
	AJ							
	AL							

OTHER REFERENCES (including Author, Title, Date, Pertinent Pages, Etc.)

	AM		
	AN		
	AO		

EXAMINER	DATE CONSIDERED

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

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